Progress in the development of a plasma based CI-source for GC-MS



Introduction

Chemical ionization mass spectrometry (CI-MS) is a technique to generate analyte ions via ionmolecule reactions. Within the GC-MS application primary reactant ions are commonly produced by electron ionization (EI) of a reagent gas. A major disadvantage of this setup is the short operative lifetime due to filament corrosion and ion source fouling induced by reagent ions.

The chemical ionization setup in this contribution uses a hydrogen plasma, which leads to the direct production of H_3^+ , one of the strongest known gas phase acids. Subsequent quantitative transformation into other reagent ions allows less exothermic protonation of analyte molecules to obtain deliberately simplified mass spectra, often with very low loss of signal due to minimized fragmentation, which can be used for quantitative analysis of mixtures.

Recently, we introduced this custom discharge chemical ionization source [1]. In this contribution, we present an advanced version of this setup for GC-MS applications.

Methods

MS	HTOF with custom ion transfer
	optics (TOFWERK AG, Thun,
	Switzenand).
Ion Source	Custom low pressure RF
	discharge source.
Gases	Nitrogen 5.0, methane 2.5,
	ethane 3.5, isobutane 2.5
	(Messer Group GmbH, Krefeld,
	Germany).
	Hydrogen 6.0, Hydrogen
	Generator NMH2 Plus (Vici AG
	International, Schenkon,
	Switzerland)
	All gases were used without
	further purification.
Analytes	Custom analyte mixtures:
	α -pinene (98 %), o-xylene and
	anisole (99 %) in hexane (99+ %),
	decane (99 %) in
	dichloromethane (99.80 %),
	(Sigma-Aldrich Chemie GmbH,
	Taufkirchen, Germany)
	All chemicals were used without
	further purification.
Gas	6890A (Agilent, Santa Clara, CA,
Chromatograph	United States) equipped with a
	custom made transferline, carrier
	gas He 5.0 (Messer Group GmbH,
	Krefeld, Germany) purified by a
	HP2 gas purifier (Vici AG
	International, Schenkon, Switzer-
	land), manual injection.



gas.



reactant gas.



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A custom low-pressure RF discharge fed by a continuous hydrogen gas flow leads to the generation of H₃⁺ ions within a hydrogen plasma (1). The discharge source consists of a helical coil resonator (HCR) providing the RF energy to sustain the discharge. The steady flow of primary reagent ions is transported through a glass tube into the first differentially pumped pressure region (0.2 – 10 mbar) of a Time-of-Flight mass spectrometer (2). A second gas flow containing a reactant gas (X) is introduced into the primary reagent ion flow to quantitatively convert H₃⁺ to XH⁺ as the active protonating species (**3**). The GC effluent containing the gaseous

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Analytical Performance

Limit of Detection

- 33 pg on column for α -pinene (estimated from S/N = 3, from a 84 pg sample)
- 209 fg on column for o-xylene (determined by calibration curve method according to DIN 32645).

Figure 13: Calibration curve of o-xylene with nitrogen as reactant gas, split 100, manual injection, ion source not heated.

Progress in Peak Shape

- Decrease of full width at half maximum (FWHM) from 0.6 s to 0.5
- Decrease of asymmetry factor from 4.7 to 1.7 (calculated by the peak half-width at 10 % peak height).

Figure 15: Extracted ion chromatogram of an anisole GC run ([M+H]⁺ signal). Before (blue line) and after (orange line) pressure and gas flow adjustment (ion source not heated).

- Standard deviation of the total ion current (45 h) < 1.5 % (cf. Fig. 16).
- Several weeks runtime with reagent gas without performance loss.

Conclusions

- Different reagent gases allow scaling of the exothermicity of the analyte protonation. This results in "soft" ionization and leads to quasimolecular ions as main ion signals.
- cf. decane + nitrogen reactant gas (Fig. 9) compared to decane + methane reactant gas (Fig. 10).
- Successful coupling of the custom build RF plasma source to a gas chromatograph with insignificant interference with the chromatographic performance (cf. Fig 15, peak tailing).
- Ion source was not heated, due to leaks during heating.
- Low fragmentation degrees and exclusive formation of quasi molecular ions.
- Decrease in fragmentation by chemical suppression of bulk gas ions (particularly H_2O).

Outlook

- Test of different sealing materials for ion source heating up to 300 °C.
- Investigation on suitable reagent ions in addition to standard CI reactant gases.
- cluster Avoid water formation as thermodynamic sink for protons by minimizing water impurities of the chosen gases.
- Measurements and simulations of kinetic data to optimize the ionization process and suppress water cluster formation.

Literature

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